

<b>Notice of References Cited</b>	Application/Control No. 10/600,637	Applicant(s)/Patent Under Reexamination HAYNER ET AL.	
	Examiner Kim-Kwok CHU	Art Unit 2627	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,462,323	10-2002	Tagawa, Yukihiro	369/44.32
*	B	US-6,298,019	10-2001	Watanabe et al.	369/53.23
*	C	US-5,627,808	05-1997	Hajjar et al.	369/44.32
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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